



E0545

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ghaemmaghami et al.

Serial No.: 09/497,320

Filed: February 3, 2000

Group Art Unit: 2815

Before the Examiner: Jose R. Diaz

Title: METHOD AND SYSTEM FOR PROVIDING HALO  
IMPLANT TO A SEMICONDUCTOR DEVICE WITH  
MINIMAL IMPACT TO THE JUNCTION CAPACITANCE

**REPLY UNDER 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action having a mailing date of June 3, 2004 (Paper No. 28), having a three-month shortened statutory period for response set to expire on September 3, 2004, please reconsider the rejections of the claims in view of the following remarks:

**Remarks begin on page 2 of this paper.**

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**CERTIFICATION UNDER 37 C.F.R. § 1.8**

I hereby certify that this correspondence (along with any item referred to as being enclosed herewith) is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 15, 2004.

  
Signature

Serena Beller  
(Printed name of person certifying)